



Patent Application 10/822,960

Docket No. 24061.187 (2003-1398)  
Customer No. 42717

IFW

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	Pey-Yuan Lee	§	Docket No.:	24061.187
		§		(2003-1398)
Serial No.:	10/822,960	§		
		§	Examiner:	Andy Huynh
Filed:	April 13, 2004	§		
		§	Art Unit:	2818
For:	Carryover Reduction in Multiple	§		
	CDSEM Line Matching	§	Conf. No.:	3594
		§		
		§		

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
Mail Stop: Amendment  
PO Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The present paper is being submitted in response to the Restriction Requirement Office Action dated June 21, 2005 in the above-identified application.

**Election of Claims** begins on page 2 of this paper.

**Amendments to the Claims** are reflected in the Listing of Claims which begins on page 3 of this paper.

**Remarks** begin on page 7 of this paper.

**I. Election**

In the Office Action mailed June 21, 2005, the Examiner alleges that the application contains claims directed to two inventions and, thus, required restriction of either:

Group I: Claims 1-9, drawn to a method of manufacturing a microelectronic device;

Group II: Claims 10-13, drawn to a method of calibrating a metrology tool;

Group III: Claims 14-16, 21 and 22, drawn to a device; and

Group IV: Claims 17-20, drawn to a method of manufacturing a calibration wafer.

In response, Applicants hereby elect Group I, corresponding to claims 1-9. Applicants' election is made with traverse on the grounds that the embodiments delineated by the Examiner are not patentably distinct and therefore constitute a single invention concept.